



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

July 31, 2025	
IGI Report Number	LG726502967
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	PRINCESS CUT
Measurements	6.09 X 5.94 X 4.24 MM

GRADING RESULTS

Carat Weight	1.30 CARAT
Color Grade	E
Clarity Grade	VS 1

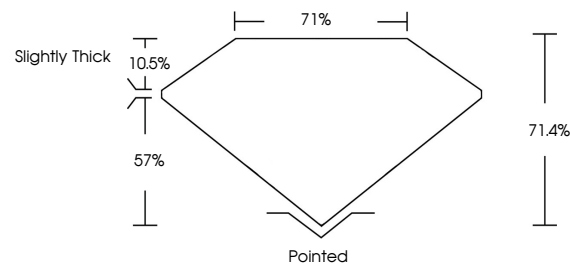
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	 LG726502967

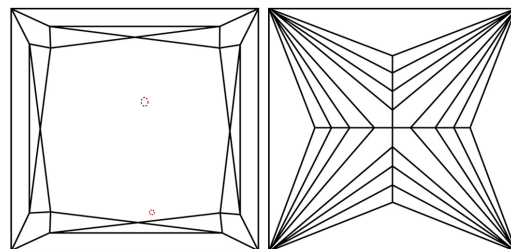
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG726502967
Report verification at igi.org

PROPORTIONS

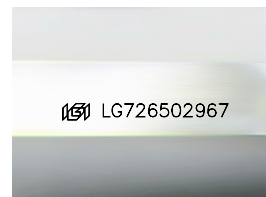


CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.



Sample Image Used

COLOR

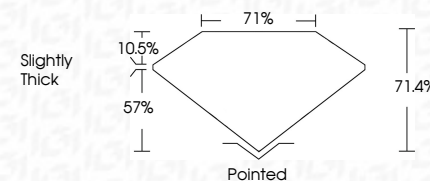
D E F G H I J Faint Very Light Light

CLARITY

IF	VS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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July 31, 2025
 LGI Report No LG726502967
 PRINCESS CLIT

5.09 X 5.94 X .424 MM	Carat Weight	1.30 CARAT
	Color Grade	E
	Clarity Grade	VS 1
	Depth	71.4%
	Table	71%
	Grade	Slightly Thick
	Culet	Pointed
	Polish	EXCELLENT
	Symmetry	EXCELLENT
	Fluorescence	NONE

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www.igi.org